



Attorney/Docket No. 24061.51 (TSMC2002-1216)  
Customer No. 27683

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Yu-Liang Hsu, et al.	§	Docket No.:	24061.51
Serial No.:	10/715,326	§	Examiner:	To Be Determined
Filed:	November 17, 2003	§	Art Unit:	2812
Entitled:	SUPERCritical WATER APPLICATION FOR OXIDE FORMATION	§	Conf. No.:	5111

INFORMATION DISCLOSURE STATEMENT

Mail Stop: Amendment  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In compliance with the duty of disclosure under 37 CFR §1.56, and in accordance with the practice under 37 CFR §1.97 and §1.98, the Examiner's attention is directed to the documents listed on the enclosed modified Form PTO-1449. No inference should be made that the cited references are in fact material, are in fact prior art, or that no better art exists. The cited patents are listed in numerical and alphabetical order and are not listed in any order based on their pertinence.

The above-identified application was filed after June 30, 2003. Therefore, pursuant to the waiver of the requirement under 37 CFR 1.98 (a)(2)(i) as stated in a Pre-OG Notice dated July 11, 2003, copies of the U.S. patents listed on the enclosed modified Form PTO-1449 are not being provided.

This Information Disclosure Statement is being filed within three months of the United States filing date or before the mailing date of a first Office Action on the merits. No certification or fee is required (37 CFR §1.97(b)).

The Commissioner is hereby authorized to charge any additional fees which may be required or credit any overpayment to Deposit Account 08-1394.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Respectfully submitted,

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Name	<u>Dayle Canner</u>
Date	<u>5-10-04</u>

In place of PTO-1449 Form		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		Complete if Known	
MAY 13 2004 <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (use as many sheets as necessary)				Application Number	10/715,326
				Filing Date	November 17, 2003
				Applicant(s)	Yu-Liang Hsu, et al.
				Art Unit	2612
				Examiner Name	To Be Determined
				Attorney Docket Number	24061.51 (TSMC2002-1216)
SHEET	1	OF	1		

U. S. PATENT DOCUMENTS				
Examiner's Initials	Cite No.	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
	AA	5,725,987	03-10-1998	Combes, et al.
	AB	6,306,754	10-23-2001	Agarwal
	AC	6,346,484	02-12-2002	Cotte, et al.
	AD	6,423,649	07-23-2002	Gealy, et al.
	AE	6,514,876	02-04-2003	Thakur, et al.
	AF	6,514,879	02-04-2003	Arghavani, et al.
	AG	6,528,431	03-04-2003	Tanabe, et al.
	AH	6,537,916	03-25-2003	Mullee, et al.
	AI	6,541,278	04-01-2003	Morita, et al.
	AJ	6,541,394	04-01-2003	Chen, et al.
	AK	6,543,156	04-08-2003	Bergman, et al.

FOREIGN PATENT DOCUMENTS					
Examiner's Initials	Cite No.	Foreign Patent Document (Country Code - Number - Kind)	Publication Date MM-DD-YYYY	Patentee or Applicant of Cited Document	Translation Y/N

OTHER PRIOR ART		
Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume-issue number(s), publisher, city/country where published
	AL	ALMANZA-WORKMAN, A. MARCIA, et al., "Water Dispersible Silanes for Wettability Modification of Polysilicon", Journal of the Electrochemical Society, 149, 2002, pp. H6-H11.
	AM	WEIBEL, GINA L., et al., "An Overview of Supercritical CO <sub>2</sub> Applications in Microelectronics Processing", Microelectronic Engineering 65, 2003, pp. 145-152.

Examiner Signature		Date Considered	
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.